











Podlepetskiy Boris I. Course Schedule

TUESDAY

16:15 — 17:50	<input checked="" type="checkbox"/> LEC Micro and Nanotechnology Sensors; Sensors Based on Micro- and Nanotechnologies  S16-401, S16-402  ДОТ <input checked="" type="checkbox"/> SEM Micro and Nanotechnology Sensors; Sensors Based on Micro- and Nanotechnologies  S16-401, S16-402  ДОТ
17:55 — 18:40	<input checked="" type="checkbox"/> LAB Micro and Nanotechnology Sensors; Sensors Based on Micro- and Nanotechnologies  S16-401, S16-402  ДОТ

WEDNESDAY

12:45 — 14:20	<input checked="" type="checkbox"/> LEC Sensors and gauges in microelectronics  M20-423  ДОТ
14:30 — 16:05	<input checked="" type="checkbox"/> SEM Sensors and gauges in microelectronics  M20-423  ДОТ